

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10824750
<b>Filing Date:</b>	15-Apr-2004
<b>Title of Invention:</b>	Method and system for immersion lithography using high PH immersion fluid
First Named Inventor/Applicant Name:	Chao -Hsiung Wang
<b>Filer:</b>	Steven E. Koffs/Amanda Orson
<b>Attorney Docket Number:</b>	TSMC2003-1412(N1280-00280)

Filed as Large Entity

### Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
Post-Allowance-and-Post-Issuance:				
<b>Extension-of-Time:</b>				
Extension - 2 months with \$0 paid	1252	1	450	450

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>450</b>